

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor D. M. Eppich
Assignee Micron Technology, Inc.
Group Art Unit unknown
Examiner unknown
Attorney's Docket No. MI22-2467
Customer No. 021567
Title: Methods of Forming Transistor Devices and Capacitor Constructions

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
Commissioner for Patents
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AMENDMENTS